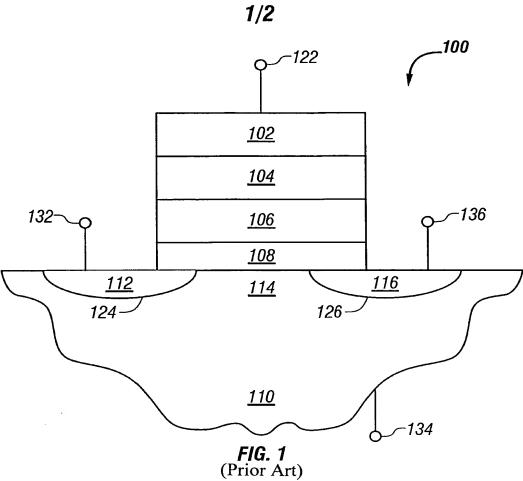
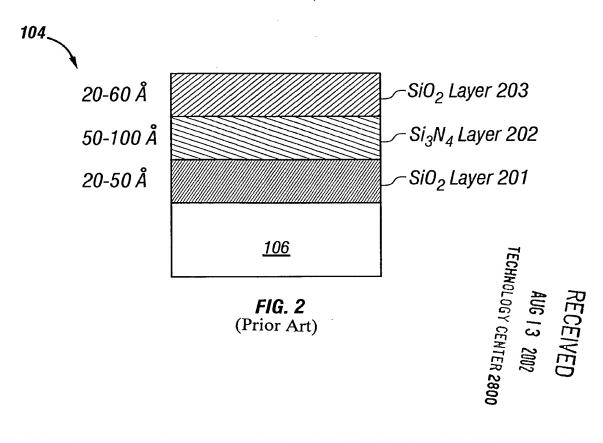


Process For Peating ONO Dielectric Film Of A Floating Late Memory Cell Appln. : 09/927,134 Inventors: Berran et al.





2/2

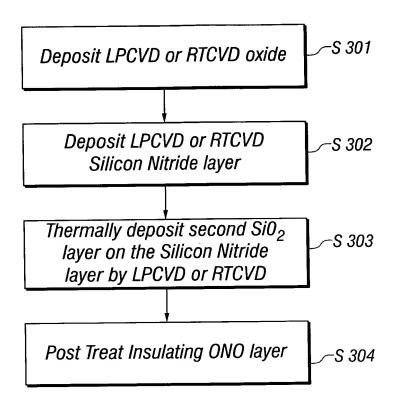


FIG. 3

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